

L Number	Hits	Search Text	DB	Time stamp
-	61598	silicon adj nitride	USPAT; US-PGPUB	2003/06/09 10:58
-	3149	"Si.sub.3N.sub.4"	USPAT; US-PGPUB	2003/06/09 10:58
-	183	"Si.sub.xN.sub.y"	USPAT; US-PGPUB	2003/06/09 10:58
-	670	atomic adj layer adj deposit\$3	USPAT; US-PGPUB	2003/06/09 10:59
-	1315	ALD	USPAT; US-PGPUB	2003/06/09 10:59
-	96	((silicon adj nitride) or "Si.sub.3N.sub.4" or "Si.sub.xN.sub.y")	USPAT; US-PGPUB	2003/06/09 11:11
-	8491	same ((atomic adj layer adj deposit\$3) or ALD)	USPAT; US-PGPUB	2003/06/09 11:11
-	237407	diffusion adj barrier	USPAT; US-PGPUB	2003/06/09 11:12
-	424	capacitor	USPAT; US-PGPUB	2003/06/09 11:12
-	424	capacitor and (((silicon adj nitride) or "Si.sub.3N.sub.4" or "Si.sub.xN.sub.y") same (diffusion adj barrier ))	USPAT; US-PGPUB	2003/06/09 14:37

L Number	Hits	Search Text	DB	Time stamp
3	8491	diffusion adj barrier	USPAT; US-PGPUB	2003/06/09 14:37
4	139815	alumina	USPAT; US-PGPUB	2003/06/09 14:38
5	24	aluminae	USPAT; US-PGPUB	2003/06/09 14:38
6	58487	aluminum adj oxide	USPAT; US-PGPUB	2003/06/09 14:39
7	14	"Al.sub.O.sub.3"	USPAT; US-PGPUB	2003/06/09 14:39
8	7692	"Al.sub.2O.sub.3"	USPAT; US-PGPUB	2003/06/09 14:39
9	370	((diffusion adj barrier) same (alumina or aluminae or (aluminum adj oxide ) or "Al.sub.O.sub.3" or "Al.sub.2O.sub.3" )	USPAT; US-PGPUB	2003/06/09 14:40
10	237407	capacitor	USPAT; US-PGPUB	2003/06/09 14:40
11	81	((diffusion adj barrier) same (alumina or aluminae or (aluminum adj oxide ) or "Al.sub.O.sub.3" or "Al.sub.2O.sub.3" )) and capacitor	USPAT; US-PGPUB	2003/06/09 14:41